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**DATE:** August 22, 2006  
**FILE NO:** APPM/006716/ETCH/SILICON/PJS  
**TO:** COMMISSIONER FOR PATENTS  
Examiner Ram N. Kackar  
**FAX NO:** 571-273-8300  
**COMPANY:** USPTO  
**FROM:** Nywell A. Houston  
Legal Assistant to Keith Tackett  
**PAGE(S) with cover:** 5  
**ORIGINAL TO FOLLOW?** ☐ YES ☒ NO

**NOTICE OF APPEAL; PETITION FOR TWO MONTH EXTENSION OF TIME**

**TITLE:** Method and System for Monitoring an Etch Process  
**U.S. SERIAL NO.:** 10/674,568  
**FILING DATE:** September 29, 2003  
**INVENTOR:** Matthew Fenton Davis, et al.  
**EXAMINER:** Ram N. Kackar  
**GROUP ART UNIT:** 1763  
**CONFIRMATION NO.:** 3852

**CONFIDENTIALITY NOTE**

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